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**CERTIFICATE OF MAILING**

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*Kim Turilli*

By: Kim Turilli  
Dated: October 24, 2003

Patent  
Atty. Docket: H37-091 DIV

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : J. Schmitt

Serial No. : 09/824,936

Filing Date : April 3, 2001

For : PLASMA REACTOR FOR THE TREATMENT  
OF LARGE SUBSTRATES

Examiner : A.M. Crowell

Group Art Unit : 1763

**Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**SUPPLEMENTAL AMENDMENT**

Sir:

In supplement to the Amendment filed October 2, 2003, attached to this Amendment please find a copy of Japanese reference JP 08-186094 to Hanada, along with a translated abstract and mechanized translation of the entire reference.

Favorable consideration is respectfully requested.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Peter C. Michalos', written over a horizontal line.

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Dated: October 24, 2003

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